

Application Data Sheet

Application Information

Application number::

Filing Date::

Application Type::

Subject Matter::

Title ::

Regular

Utility

METHOD FOR
MANUFACTURING
SEMICONDUCTOR DEVICE
AND HEAT TREATMENT
METHOD

Attorney Docket Number::

0756-7201

Total Drawing Sheets::

13

Small Entity?::

No

Applicant Information

Applicant Authority Type::

Inventor

Primary Citizenship Country::

Japan

Given Name::

Toru

Middle Name::

Family Name::

TAKAYAMA

Name Suffix::

City of Residence::

Atsugi

State or Province of Residence::

Kanagawa

Country of Residence::

Japan

Street of mailing address:: c/o Semiconductor Energy
Laboratory Co., Ltd., 398,
Hase
City of mailing address:: Atsugi-shi
State or Province of mailing address:: Kanagawa-ken
Country of mailing address:: Japan
Postal or Zip Code of mailing address:: 243-0036

Applicant Authority Type:: Inventor
Primary Citizenship Country:: Japan
Given Name:: Shunpei
Middle Name::
Family Name:: YAMAZAKI
Name Suffix::
City of Residence:: Setagaya
State or Province of Residence:: Tokyo
Country of Residence:: Japan
Street of mailing address:: c/o Semiconductor Energy
Laboratory Co., Ltd., 398,
Hase
City of mailing address:: Atsugi-shi
State or Province of mailing address:: Kanagawa-ken
Country of mailing address:: Japan
Postal or Zip Code of mailing address:: 243-0036

Applicant Authority Type:: Inventor
Primary Citizenship Country:: Japan
Given Name:: Tetsuji

Middle Name::
Family Name:: YAMAGUCHI
Name Suffix::
City of Residence:: Atsugi
State or Province of Residence:: Kanagawa
Country of Residence:: Japan
Street of mailing address:: c/o Semiconductor Energy
Laboratory Co., Ltd., 398,
Hase
City of mailing address:: Atsugi-shi
State or Province of mailing address:: Kanagawa-ken
Country of mailing address:: Japan
Postal or Zip Code of mailing address:: 243-0036

Correspondence Information

Correspondence Customer Number :: 31780
E-Mail address:: erobinson@riplo.com

Representative Information

Representative Customer Number:: 31780

Domestic Priority Information

Application ::	Continuity Type::	Parent Application::	Parent Filing Date::

Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
Japan	2002-276402	09/20/2002	Yes

Assignee Information

Assignee name::	Semiconductor Energy Laboratory Co., Ltd.
Street of mailing address::	398 Hase
City of mailing address::	Atsugi-shi
State or Province of mailing address::	Kangawa-ken
Country of mailing address::	Japan
Postal or Zip Code of mailing address::	243-0036